

Transaction Information

Tool ID	NITDE-03
Tool Status	Connected
Location	Singapore
Wafer Size	200 mm
Fab Section	Diffusion
Tool Available Date	2024-10-06

General Product Information

Vendor Supplier	TOKYO ELECTRON LIMITED
Model	ALPHA-808S
Vintage	1995
Serial No	3000095Z5347
Asset Description	NITDE-03
Software Version	7.03 Rev1
CIM	SECS
Process	NITDE Deposition

Hardware Configuration (Fab)

System Type	Description	Quantity	Status
Handler System	Wafer Transfer Robot	1	OK
Factory Interface	SMIF		
Options System			
Others			
Main System	Main Body	1	OK

Hardware Configuration (Subfab / Auxilliary Units)

Description	Quantity	Status
None		

Missing/Faulty Parts / Accesories List

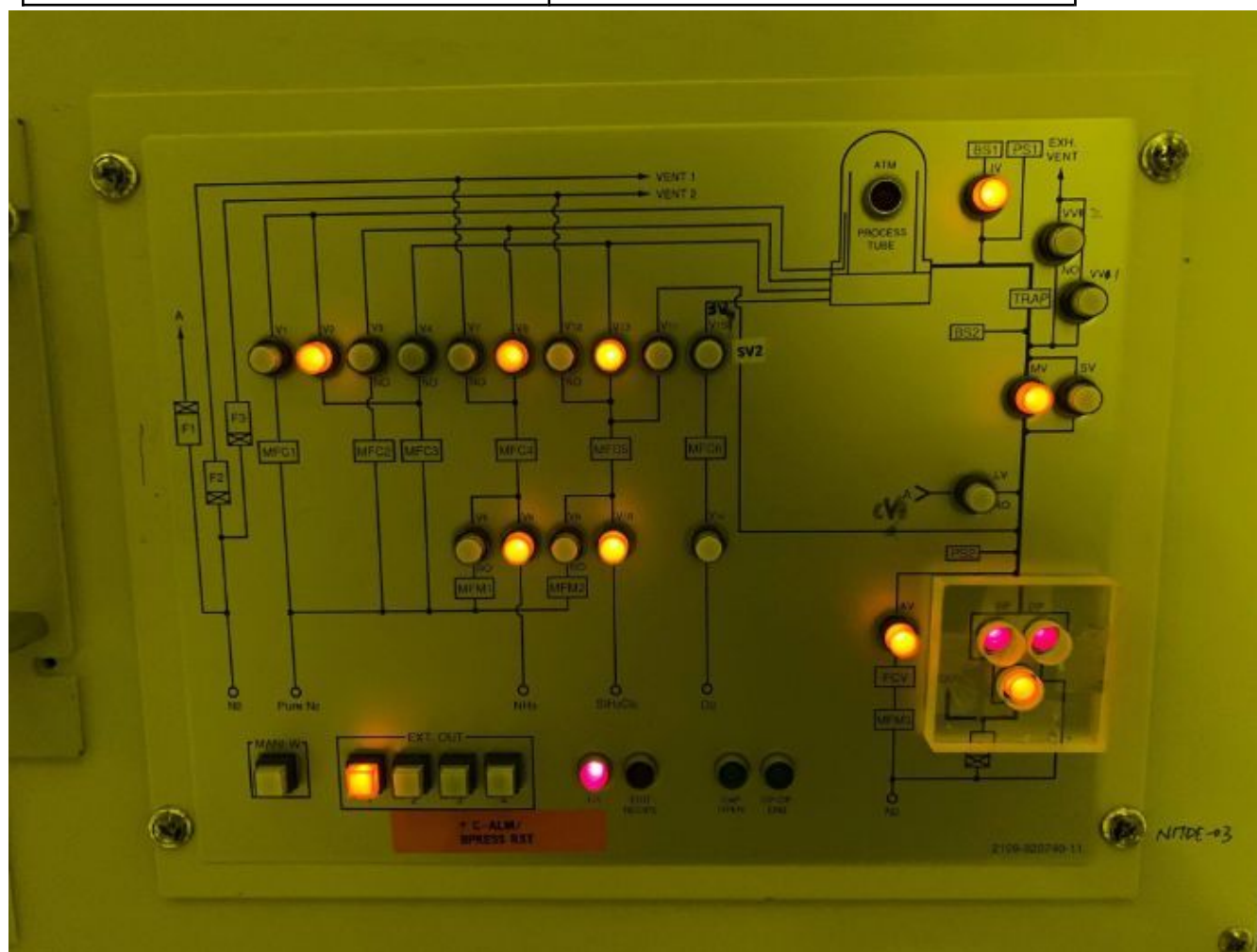
Description	Quantity
Quartzware/SiC is NOT included	

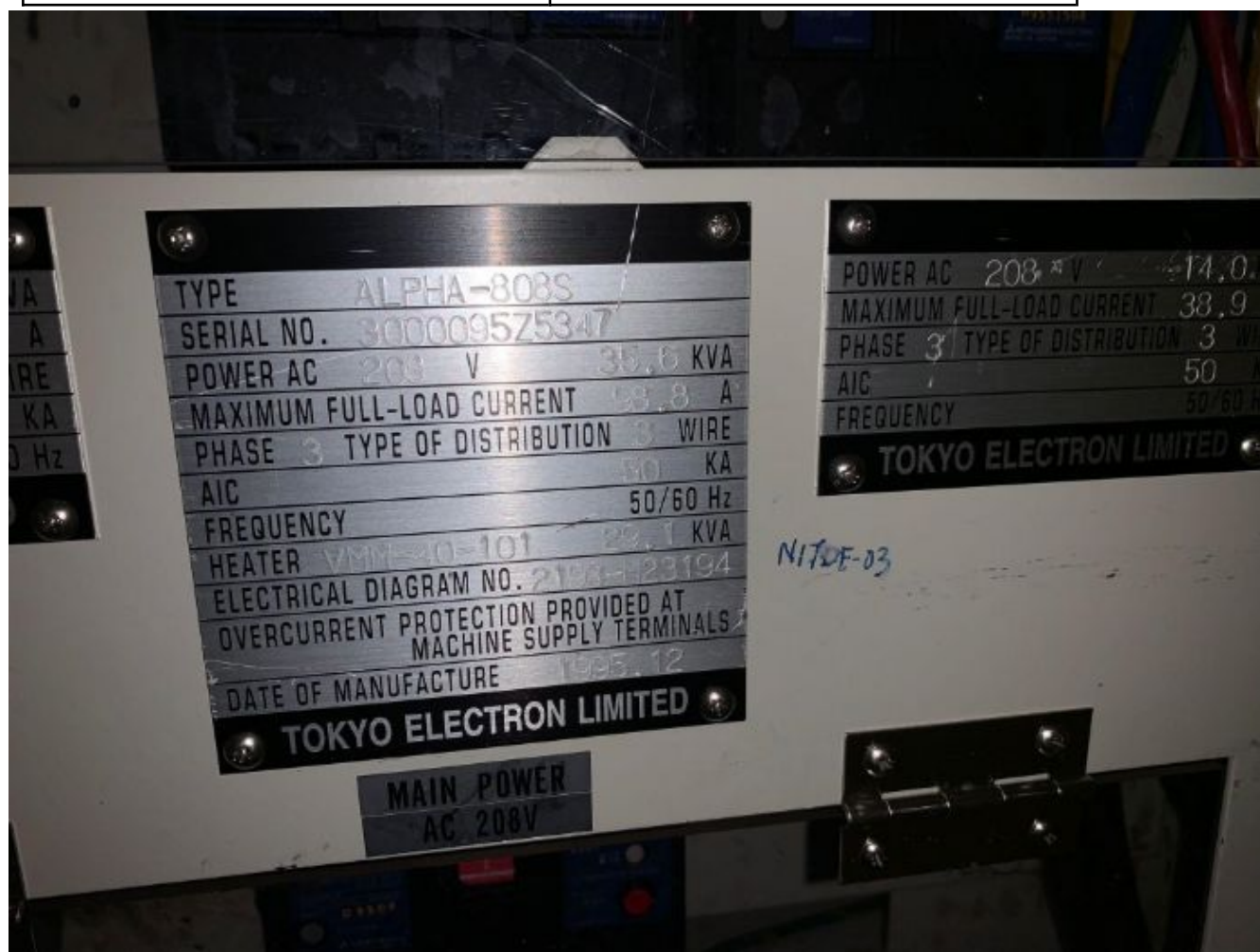
Tool Pictures

General

Nitde-03







PLEASE START A CTL UP. PLEASE START THE T-BAWL
NORMALIZE AFTER CHECKING A/S POSITION.

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NITDE-03 HIA20

TS4000Z

		STATUS						
DISPLAY OFF	READ MAIL	ALARM	POWER FAIL	STANDBY	ALARM LOG	TEMP	GAS	WHOLE
Ver/Rev INFORMATION		Ver		Rev		SET BAKING		
DISPLAY Ver/Rev	CPU-M	U07.03	R0001				T-BAWL	
PROCESS RESULT	CPU-P	U07.03	R0004					
	CPU-T	U07.00	R0027					
	CPU-S	U46.01	R1014					
	CPU-I/O(P)	U01.19	RP21220-0					
	CPU-I/O(T)	U07.01	R0003					
TOKYO ELECTRON TOHOKU LIMITED				SHIFT				
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WRITE MAIL	EDIT PROFILE	SET	DISPLAY	EDIT	SET INITIAL	SET CLOCK.	SET VDATA	ESC
RECIPE								



Additional Tool Data Files